

# **nanoFAB Online Sample Submission Procedure**

Feb. 22nd, 2019

## nanoFAB

## Laboratory Management &amp; Access Control System (LMACS)

Manage ▾

Facility ▾

Equipment ▾

Photomasks

Requests

Tasks

Requests

Currently Logged In

Facility Notices

Create Reservation

1. Log onto LMACS
2. Click ***“Requests”*** button

## nanoFAB

## Laboratory Management &amp; Access Control System (LMACS)

Manage ▾

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Photomasks

Requests

Manage Requests

## Submit a New Request

## 3. Fill in general information

- Select Type – **“Sample”**
- **“Return any Samples”** - Indicate whether you like samples to be returned or not upon completion of analysis.
- Click **“Create Request”** button

Title  
XPS analysis.

Select Project  
Nanofab.Process\_Development x ▾

Select Type  
Sample x ▾

Select Equipment (optional)  
XPS Imaging Spectrometer (Kratos AXIS Ultra) x ▾

Summary  
I would like to submit 4 samples for XPS analysis.

Return any samples

You can attach additional information (files/steps..) in the next step

Create Request

# nanoFAB

## Laboratory Management & Access Control System (LMACS)

Manage ▾

Facility ▾

Equipment ▾

Photomasks

Requests

### Submit a New Request

Manage Requests

#### That's it!

You've completed the minimum information required to get started. If you would like to add additional information to your request, you can click the "Edit Request" button. You can also view / edit your other pending requests from the list below.

Edit Request

### Pending Requests

14 results

Title	Submitted	Modified	Status
XPS analysis. Sample	Mar 5th	Mar 5th	Submitted

4. Click **“Edit Request”** to add detailed description of samples and analysis.

5. Edit sample details in “**Add item(s)**” session:

- One sample per item
- Sample name in Label
- Select “**Sample**” type
- Add sample information and analysis details in “**description**”
- Click “**Add Item**”

The screenshot displays the nanoFAB LMACS interface. At the top, a green header contains the text "nanoFAB Laboratory Management & Access Control System (LMACS)". Below this is a navigation bar with tabs for "Manage", "Facility", "Equipment", "Photomasks", and "Requests". The user's name "Peng Li" and an "Admin" dropdown are visible on the right. The main content area is titled "XPS analysis." and shows "Request ID: 2172". On the right side, it says "Submitted by: Peng Li".

The interface is divided into several sections:

- Item Details:** A yellow box with the text "Empty" and "No items have been added to this request yet."
- Comments:** A text input field with the placeholder "add your comment...", an "Add Comment" button, and a "private" checkbox.
- History:** A table with two entries:

Mar 5, 2017 10:04pm	Peng Li <b>changed</b> Assigned To From: nobody To: Peng Li
Mar 5, 2017 10:04pm	Peng Li initially <b>created</b> this request.
- Add Item(s) Form:** A form with the following fields:
  - Label:** Text input containing "SiO2 nanoparticles (###)".
  - Type:** Dropdown menu with "Sample" selected.
  - Select Equipment (if applicable):** Dropdown menu with "XPS Imaging Spectrometer (Kratos AXIS Ultra)" selected.
  - Due Date:** Text input with "optional due date" and a calendar icon.
  - Assign To:** Text input with "Assign Users" below it.
  - Description:** Text area containing "Survey scan and high resolution scan of Si and O."
  - Add Item:** A button at the bottom of the form.

XPS analysis.


Request ID: 2172

Submitted by: Peng Li

Include

Comments  Files  Bookings  Item Details

6. Print your request after completing editing sample details.

- a. Click 
- b. Check **"Item details"**
- c. check **"comments"** if needed
- d. Click **"Print Request"**
- e. A PDF is generated

Item Details 4

Label	Type	Description	Assigned	Resource
1 SiO2 nanoparticles (###)	Sample	Survey scan and high resolution scan of Si and O.	Peng Li	XPS Imaging Spectrometer (Kratos AXIS Ultra) <small>Edit</small>
ID: 2172-1686 <span style="float: right;">Submitted</span>				
2 TiO2 nanoparticles (###)	Sample	Survey scan and high resolution scan of Ti and O.	Peng Li	XPS Imaging Spectrometer (Kratos AXIS Ultra) <small>Edit</small>
ID: 2172-1687 <span style="float: right;">Submitted</span>				
3 TiO2 thin film (###)	Sample	Survey scan and high resolution scan of Ti and O a...	Peng Li	XPS Imaging Spectrometer (Kratos AXIS Ultra) <small>Edit</small>
ID: 2172-1688 <span style="float: right;">Submitted</span>				
4 TiO2 thin film (###)	Sample	Survey scan and high resolution scan of Ti and O a...	Peng Li	XPS Imaging Spectrometer (Kratos AXIS Ultra) <small>Edit</small>
ID: 2172-1689 <span style="float: right;">Submitted</span>				

Summary Submitted

Add Item(s)

Label: TiO2 thin film (###)

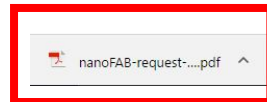
Type: Sample

Select Equipment (if applicable): XPS Imaging Spectrometer (Kratos AXIS Ultra)

Due Date: optional due date

Assign To: Assign Users

Description: Sample: 20nm TiO2 film on Si substrate.



7. Print a hard copy, attach it to your samples and submit them to the nanoFAB Characterization Lab (ECERF W1-040)

Please include your request ID and Item ID in any related communication with nanoFAB staff members.

nanoFAB Request Detail		Printed: Mar 5, 2017
<b>XPS analysis.</b>		<b>Request ID: 2172</b>
Project: Nanofab.Process_Development	Submitted By: Peng Li	
Status: Submitted	Submitted Date: Mar 5, 2017	
Type: Sample	Last Modified: Mar 5, 2017	
Priority:	Due Date:	
Equipment: XPS Imaging Spectrometer (Kratos AXIS Ultra)	Assigned To: Peng Li	
Description: I would like to submit 4 samples for XPS analysis.		
<b>Items (4)</b>		
<b>ID: 2172-1686: SiO2 nanoparticles (####) (Sample)</b>		
Equipment: XPS Imaging Spectrometer (Kratos AXIS Ultra)	Status: Submitted	Submitted: Mar 5, 2017
Survey scan and high resolution scan of Si and O.		
<b>ID: 2172-1687: TiO2 nanoparticles (####) (Sample)</b>		
Equipment: XPS Imaging Spectrometer (Kratos AXIS Ultra)	Status: Submitted	Submitted: Mar 5, 2017
Survey scan and high resolution scan of Ti and O.		
<b>ID: 2172-1688: TiO2 thin film (####) (Sample)</b>		
Equipment: XPS Imaging Spectrometer (Kratos AXIS Ultra)	Status: Submitted	Submitted: Mar 5, 2017
Survey scan and high resolution scan of Ti and O and depth profile measurement of Ti and O.		
Sample: 10nm TiO2 film on Si substrate.		
<b>ID: 2172-1689: TiO2 thin film (####) (Sample)</b>		
Equipment: XPS Imaging Spectrometer (Kratos AXIS Ultra)	Status: Submitted	Submitted: Mar 5, 2017
Survey scan and high resolution scan of Ti and O and depth profile measurement of Ti and O.		
Sample: 20nm TiO2 film on Si substrate.		
<b>Any samples submitted will be discarded. If you wish to have your samples returned, contact the nanoFAB</b>		

Request ID: 2172

## 8. Files and Comments:

- Results will be uploaded in the **“Files”** session after completion of analysis.
- Users can also upload related documents here
- Communication is best through **“Comments”** session.

Comments
  Files
  Bookings
  Item Details

#### Item Details 4

Label	Type	Description	Assigned	Resource
1 SiO2 nanoparticles (####)	Sample	Survey scan and high resolution scan of Si and O.	Peng Li	XPS Imaging Spectrometer (Kratos AXIS Ultra)
ID: 2172-1686 <span style="float: right;">Submitted</span>				
2 TiO2 nanoparticles (####)	Sample	Survey scan and high resolution scan of Ti and O.	Peng Li	XPS Imaging Spectrometer (Kratos AXIS Ultra)
ID: 2172-1687 <span style="float: right;">Submitted</span>				
3 TiO2 thin film (####)	Sample	Survey scan and high resolution scan of Ti and O a...	Peng Li	XPS Imaging Spectrometer (Kratos AXIS Ultra)
ID: 2172-1688 <span style="float: right;">Submitted</span>				
4 TiO2 thin film (####)	Sample	Survey scan and high resolution scan of Ti and O a...	Peng Li	XPS Imaging Spectrometer (Kratos AXIS Ultra)
ID: 2172-1689 <span style="float: right;">Submitted</span>				

#### Summary Submitted

#### Add Item(s)

Label  
TiO2 thin film (####)

Type  
Sample

Select Equipment (if applicable)  
XPS Imaging Spectrometer (Kratos AXIS Ultra)

Due Date  
optional due date

Assign To  
Assign Users

Description  
Sample: 20nm TiO2 film on Si substrate.

#### Comments 0

add your comment...

**You must have something to say**

#### Files 0

Drag & Drop Files



## 9. Sample Pickup

- Returning samples are to be picked up at the Characterization Lab (**ECERF W1-040**).

## 10. Data processing and software training

- Analysis softwares are available at the common computers in **ECERF W1-028**
- Should you require software training (CasaXPS, JADE-XRD, Oxford EDX, JEOL EDX, SIMS), please submit a training request on LMACS - select tool “**Characterization software.**”.

Characterization staff members:

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